

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Akiko YOSHIDA, et al.

GROUP: 1724

SERIAL NO: 10/510,964

FILED: November 1, 2004

EXAMINER: BARRY, CHESTER T

FOR: ION ADSORPTION MODULE AND WATER TREATMENT METHOD

SUBMISSION OF SUPPLEMENTAL APPLICATION DATA SHEET

Office of Initial Patent Examination
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

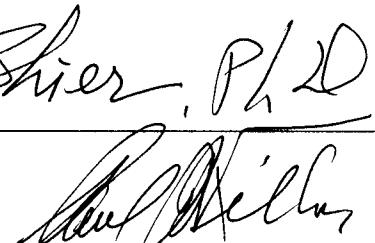
Applicant(s) submit herewith a Supplemental Application Data Sheet for the above-identified application for the purpose of correcting the domestic priority information.

Respectfully Submitted,

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